# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Atty. Dkt. No. 5298-02501 PM98019C

Inventor(s):

Anantha R. Sethuraman Christopher A. Seams

PLANARIZED SEMICONDUCTOR Title:

INTERCONNECT TOPOGRAPHY AND METHOD FOR POLISHING A METAL LAYER TO FORM

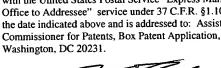
INTERCONNECT

CERTIFICATE OF EXPRESS MAIL UNDER 37 C.F.R. § 1.10

"Express Mail" mailing label no. EL726370210US Date of Deposit: February 7, 2001

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Derrick Brown



# UTILITY PATENT APPLICATION TRANSMITTAL

(For new non-provisional applications under 37 CFR § 1.53(b))

This is a Continuation Application of prior application no. 09/143,723 filed August 31, 1998 and assigned to Cypress Semiconductor, recorded at Reel 9435, Frame 0506.

## Enclosed are the following items:

- A fee authorization for the amount of \$710.00. 1.
- Request & Certification under 35 U.S.C. 122(b)(2)(B)(i). 2.
- Specification as originally submitted including informal drawings. 3.
- Formal drawings of Figs. 1 8 on 3 sheets. 4.
- Copy of Declaration/Power of Attorney from prior application (see 37 CFR 1.63(d)). 5.
- Copy of Assignment papers from prior application. 6.
- Information Disclosure Statement w/form PTO-1449. 7.
- 8. Return receipt postcard(s).

Please amend the specification by inserting before the first line the sentence: -This is a

continuation application from prior application no. 09/143,723, filed August 31, 1998.



դրում կում - իր են եր հայաստան են քան իրում որ հում իրում ուժեր ուժեր հայաստանում - իրում ուժեր ուժեր հում եր

Respectfully submitted,

Kevin L. Daffer Reg. No. 34,146

Attorney for Applicants

Conley, Rose & Tayon P.O. Box 398 Austin, TX 78767-0398 Date: February 7, 2001

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Derrick Brown

### **FEE AUTHORIZATION**

Assistant Commissioner for Patents Washington, D.C. 20231

The Commissioner is hereby authorized to charge the following fee to Conley, Rose & Tayon, P.C. deposit account no. 50-1505/5298-02501\*.

Item:

Filing fee

Amount:

\$710.00

Atty. Dkt. No.

5298-02501

Respectfully submitted,

Kevin L. Daffer

Reg. No. 34,146

Attorney for Applicants

Conley, Rose & Tayon P.O. Box 398 Austin, TX 78767-0398

Date: February 7, 2001

<sup>\*</sup> If the above listed account is found to have insufficient funds, the Commissioner is authorized to charge Conley, Rose & Tayon, P.C. deposit account no. 50-1623/5298-02501.

PTO/SB/35 (11-00)
App
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Assistant Commissioner for Patents Box Patent Application Washington, DC 20231

Derrick Brown

# REQUEST AND CERTIFICATION UNDER 35 U.S.C. 122(b)(2)(B)(i)

Atty Docket Number: 5298-02501

First Named Inventor: Anantha R. Sethuraman et al.

Title: PLANARIZED SEMICONDUCTOR

INTERCONNECT TOPOGRAPHY AND METHOD FOR POLISHING A METAL LAYER TO FORM

INTERCONNECT

I hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing. I hereby request that the attached application not be published under 35 U.S.C. 122(b).

February 7, 2001
Date

Kevin L. Daffer, Reg. No. 34,146

This request must be signed in compliance with 37 CFR 1.33(b) and submitted with the application **upon filing**.

Applicant may rescind this nonpublication request at any time. If applicant rescinds a request that an application not be published under 35 U.S.C. 122(b), the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

If applicant subsequently files an application directed to the invention disclosed in the attached application in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing, the applicant must notify the United States Patent and Trademark Office of such filing within forty-five (45) days after the date of the filing of such foreign or international application. Failure to do so will result in abandonment of this application (35 U.S.C. 122(b)(2)(B)(iii)).

Burden Hour Statement: This collection of information is required by 37 CFR 1.213(a). The information is used by the public to request that an application not be published under 35 U.S.C. 122(b) (and the PTO to process that request). Confidentially is governed by 35 U.S.C. 122 and 37 CFR 1.14. This form is estimated to take 6 minutes to complete. This time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.